

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Attorney Docket: SLA0809
Inventor: Apostolos T. Voutsas, et al. Confirmation No. 1722
Serial No.: 10/713,383 Group #: 1722
Filed: November 13, 2003 Examiner: R. M. Kunemund
Title: METHOD AND PROCESS FOR LONG CRYSTAL LATERAL GROWTH IN
SILICON FILMS BY UV AND IR PULSE SEQUENCING

Commissioner for Patents
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I hereby appoint Gerald Maliszewski, of P. O. Box 270829, San Diego, CA 92198-2829, U. S. Patent and Trademark Office Registration Number 38,054, as an associate attorney for the above-captioned matter, with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

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Respectfully submitted,


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